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CONFIRMATION NO. 5511

SERIAL NUMBER 10/551,695	FILING or 371(c) DATE 09/30/2005 RULE	CLASS 428	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 061063-0318214	
APPLICANTS Yoshinobu Nakada, Ageo-shi, JAPAN; Hiroyuki Shiraki, Ichikawa-shi, JAPAN; Takeshi Hasegawa, Yonezawa-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/04508 03/30/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-97365 03/31/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/10/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/SHAMIM AHMED/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 7	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 3
ADDRESS PILLSBURY WINTHROP SHAW PITTMAN, LLP Eric S. Cherry - Docketing Supervisor P.O. BOX 10500 MCLEAN, VA 22102 UNITED STATES					
TITLE Silicon wafer heat treatment jig, and silicon wafer heat treatment method					
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		